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PATENT  
SOEI/0011

JC921 U.S. PTO  
10/23/01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

BOX PATENT APPLICATION  
Assistant Commissioner for Patents  
Washington, D.C. 20231

| CERTIFICATE UNDER 37 CFR 1.10  |  |
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| I hereby certify that this correspondence and the documents referred to as attached therein are being deposited on October 23, 2001 with the United States Postal Service in an envelope as "Express Mail Post Office to Addressee," mailing label No. EL870882485US addressed to: Box Patent Application, Assistant Commissioner for Patents, Washington, D.C. 20231. |  |
| Date<br><u>23 Oct 2001</u>   | Signature<br><u>William B. Patterson</u> |

Re: Inventor(s): Suzuki, et al.  
Title: Method of Forming Film, Method of Manufacturing Semiconductor Device and Film Forming Apparatus

Transmitted herewith is the patent application identified above, including:

- ☒ Specification, claims and abstract 24 Total Pages
- ☒ Drawings ☒ Formal ☐ Informal 12 Total Pages
- ☒ Executed Declaration and Power of Attorney
- ☐ Information Disclosure Statement with List
- ☒ Assignment of the Invention to Applied Materials, Inc.
- ☐ Assignment Recordation Cover Sheet

JC955 U.S. PTO  
10/004489  
10/23/01

FEE CALCULATION

|  | NUMBER OF CLAIMS FILED | LESS NUMBER PAID BY BASIC FEE | NUMBER OF EXTRA CLAIMS (Not less than zero) | LARGE ENTITY FEE |
|--|------------------------|-------------------------------|---|------------------|
| Basic Fee  |                        |                               |   | \$740.00         |
| Total Claims   | 20                     | - 20 = 0                      | X \$. =                                     | .00              |
| Independent Claims                                   | 3                      | - 3 = 0                       | X \$. =                                     | .00              |
| First Presentation of Multiple Dependent Claims +250 |                        |                               |   | -0-              |
| Total Filing Fee Calculation                         |                        |                               |   | 740.00           |

- ☒ The Commissioner is hereby authorized to charge 740 to Deposit Account No. 20-0782/SOEI/0011. **A duplicate copy of this transmittal is enclosed.**
- ☒ The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 20-0782/SOEI/0011. **A duplicate copy of this transmittal is enclosed.**
- ☒ Please address all future correspondence to:  
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Respectfully submitted,

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UNITED STATES PATENT APPLICATION FOR:

METHOD OF FORMING FILM, METHOD OF MANUFACTURING  
SEMICONDUCTOR DEVICE, AND FILM FORMING APPARATUS

INVENTORS:

YOICHI SUZUKI  
TSUTOMU SHIMAYAMA

ATTORNEY DOCKET NUMBER: SOEI/0011

CERTIFICATION OF MAILING UNDER 37 C.F.R. 1.10

I hereby certify that this New Application and the documents referred to as enclosed therein are being deposited with the United States Postal Service on October 23, 2001, in an envelope marked as "Express Mail United States Postal Service", Mailing Label No. EK870882485US, addressed to: Assistant Commissioner for Patents, Box PATENT APPLICATION, Washington, D.C. 20231.

William B. Patterson  
Signature

William B. Patterson  
Name

23 October 2001  
Date of signature